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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
HAVING GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**

Customer Number: **38834**

**SUPPLEMENTAL AMENDMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

September 23, 2005

Sir:

In response to the Office Action dated March 22, 2005, and further in response to the Notice of Non-Responsive Amendment dated August 26, 2005, Applicants submit the following remarks, which begin on page 2 of this paper.